

<b>Notice of References Cited</b>	Application/Control No. 10/572,855		Applicant(s)/Patent Under Reexamination SHIMADA ET AL.	
	Examiner JOHN K. KIM		Art Unit 2834	Page 1 of 1

**U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-2003/0201685	10-2003	Shimada et al.	310/156.53
*	B	US-2002/0114824	08-2002	Fukui et al.	424/432
	C	US-			
	D	US-			
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	F	US-			
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	I	US-			
	J	US-			
	K	US-			
	L	US-			
	M	US-			

**FOREIGN PATENT DOCUMENTS**

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	N					
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**NON-PATENT DOCUMENTS**

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